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**CONFIRMATION NO. 7849** 

RULE 361 2841 DOCKET NO. IIZ 123  APPLICANTS Shinji Ohuchi, Tokyo, JAPAN; Yasushi Shiraishi, Tokyo, JAPAN; Yasuo Tanaka, Tokyo, JAPAN; ** CONTINUING DATA **********************************	SERIAL NUMBER	FILING DATE 04/27/2001	CLACO	T			
Shinji Ohuchi, Tokyo, JAPAN; Yasushi Shiraishi, Tokyo, JAPAN; Yasuo Tanaka, Tokyo, JAPAN;  **CONTINUING DATA **********************************				•		DOCKET NO.	
Weiffled and Allowancy Japan   Country Japan	Shinji Ohuchi, To Yasushi Shiraish Yasuo Tanaka, T ** CONTINUING DATA ** FOREIGN APPLICAT JAPAN 2000-128 IF REQUIRED, FOREIG ** 06/22/2001 Foreign Priority claimed	i, Tokyo, JAPAN; okyo, JAPAN; okyo, JAPAN;  ***********************************	RANTED	SUSTRA	,		
RABIN & CHAMPAGNE, P.C. Steven M. Rabin SUITE 500 1101 14th STREET Washington ,DC 20005  TITLE  Semiconductor apparatus and method for fabricating the same  FILING FEE RECEIVED 876  FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT	Verified and Acknowledged	oscer II hite	COUNTRY JAPAN	DRAWING	CLAIMS	CLAIMS	
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